

**Amendments to the Specification**

Please amend Paragraph [0065], as designated in the application as filed (or Paragraph [0072] in the published application as published), as follows:

[0072] Concepts have been illustrated with the use of a particular hydrodynamic focusing system, although those having an ordinary level of skill in the art, and the benefit of the present disclosure, will appreciate that embodiments of the invention may be practiced with a wide variety of hydrodynamic focusing systems. For example, an embodiment of the invention may be practiced with the hydrodynamic focusing system shown in FIG. 11. As another example, various embodiments of the invention may be practiced with the hydrodynamic focusing systems discussed in U.S. Pat. No. 5,858,187, U.S. Pat. No. 6,120,666, U.S. Pat. No. 6,159,739, and U.S. Pat. No. 6,506,609. As yet another example, an embodiment of the invention may be practiced with recursive hydrodynamic focusing using the hydrodynamic focusing system shown in FIG. 12, which includes a plurality of focusing manifolds in series. As a further example, an embodiment of the invention may be practiced with one of the hydrodynamic focusing systems disclosed in co-pending U.S. patent application Ser. No. 10/609,227, entitled "HYDRODYNAMIC FOCUSING DEVICES", filed on June 26, 2003, by Sundararajan et al. These hydrodynamic focusing systems may allow forming a coating, pillars, or other structures on all walls of an outlet channel, forming a tilted structure, or allow greater control over the shape and positioning of a formed structure.